



2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Hisashi OHTANI et al )  
Serial No. 09/197,767 ) Group Art Unit: 2814  
Filed: November 23, 1998 ) Examiner: Cao, Phat X.

For: SEMICONDUCTOR DEVICE AND )  
PROCESS FOR PRODUCING THE )  
SAME )

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
The United States Postal Service with sufficient postage as First  
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*April Campbell*

**REQUEST FOR ACKNOWLEDGMENT OF  
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

Applicants acknowledge with appreciation the Official Action mailed December 19, 2001.

The Official Action did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed October 31, 2001. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the Information Disclosure Statement of October 31, 2001 by providing a copy of the initialed Form PTO-1449.

If a conference would beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,

  
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